

Attorney Docket No. 970.1011

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Toshiaki KAKEMURA et al.

Application No.: 10/529,362

Group Art Unit: 1792

Confirmation No. 4778

Filed: March 28, 2005

Examiner: BURKHART, ELIZABETH A

Confirmation No.: 4778

For:

THIN FILM FORMING METHOD, THIN FILM FORMING DEVICE, AND THIN FILM

FORMING PROCESS MONITORING METHOD

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

This is responsive to the Office Action mailed June 9, 2008, and having a period for response set to expire on July 9, 2008. Applicants elect the invention of Group I and claims 1-5 related thereto. Applicants reserve the right to further prosecute without prejudice the non-elected inventions of Group II and Group III, and claims readable thereon.

If there are any additional fees associated with this Response, please charge the same to our Deposit Account No. 19-3935.

Respectfully submitted,

STAAS & HALSEY LLP

Date: July 1, 2008

David M. Pitcher

Registration No. 25,908

1201 New York Ave, N.W. 7th Floor

Washington, D.C. 20005 Telephone: (202) 434-1500 Facsimile: (202) 434-1501